Viviana Mulloni

List of Publications by Year in Descending Order

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The third column is the impact factor (IF) of the journal, and the fourth column is the number of citations of the article.

62 838 16 27 g-index

70 954 2.5 4.23 ext. papers ext. citations avg, IF L-index

#	Paper	IF	Citations
62	Chipless RFID Sensing System for Precise Ethanol Determination in Alcoholic Solutions. <i>Electronics</i> (Switzerland), 2022 , 11, 735	2.6	O
61	Improving the Sensitivity of Chipless RFID Sensors: The Case of a Low-Humidity Sensor. <i>Electronics</i> (Switzerland), 2021 , 10, 2861	2.6	4
60	Aluminum doped zinc oxide coatings at low temperature by atmospheric pressure plasma jet. <i>Thin Solid Films</i> , 2020 , 708, 138118	2.2	5
59	Chipless RFID Sensors for the Internet of Things: Challenges and Opportunities. Sensors, 2020, 20,	3.8	35
58	DESIGN OF AN ULTRA WIDE BAND ANTENNA BASED ON A SIW RESONATOR. <i>Progress in Electromagnetics Research C</i> , 2020 , 103, 187-197	0.9	
57	Precise dot inkjet printing thought multifactorial statistical optimization of the piezoelectric actuator waveform. <i>Flexible and Printed Electronics</i> , 2020 , 5, 045002	3.1	13
56	A Preliminary Microwave Frequency Characterization of a Nafion-Based Chipless Sensor for Humidity Monitoring 2020 ,		5
55	Instability and Drift Phenomena in Switching RF-MEMS Microsystems. <i>Actuators</i> , 2019 , 8, 15	2.4	
54	A dry film technology for the manufacturing of 3-D multi-layered microstructures and buried channels for lab-on-chip. <i>Microsystem Technologies</i> , 2019 , 25, 3219-3233	1.7	2
53	A comparative study of the refractive index of silk protein thin films towards biomaterial based optical devices. <i>Optical Materials</i> , 2018 , 78, 407-414	3.3	37
52	Continuous extraction of proteins with a miniaturized electrical split-flow cell equipped with suspended splitters fabricated by dry film lamination. <i>Sensors and Actuators B: Chemical</i> , 2018 , 273, 627	-8354	5
51	A Continuous Flow Microelectrophoretic Module for Protein Separation. <i>Lecture Notes in Electrical Engineering</i> , 2018 , 107-113	0.2	
50	Cycling reliability of RF-MEMS switches with Gold P latinum multilayers as contact material. <i>Microsystem Technologies</i> , 2017 , 23, 3843-3850	1.7	9
49	Fabrication of Nanoscale Patternable Films of Silk Fibroin Using Benign Solvents. <i>Macromolecular Materials and Engineering</i> , 2017 , 302, 1700110	3.9	25
48	A Miniaturized SPLITT System for On-Line Protein Separation. <i>Proceedings (mdpi)</i> , 2017 , 1, 527	0.3	
47	An accelerated thermal cycling test for RF-MEMS switches. <i>Microsystem Technologies</i> , 2016 , 22, 1585-15	5 9 2 ₇	3
46	Temperature as an accelerating factor for lifetime estimation of RF-MEMS switches. <i>Microelectronic Engineering</i> , 2016 , 160, 63-67	2.5	10

(2011-2016)

45	Preconditioning Procedure for the Better Estimation of the Long-Term Lifetime in Microelectromechanical Switches. <i>IEEE Transactions on Electron Devices</i> , 2016 , 63, 1274-1280	2.9	6	
44	Design of an electrophoretic module for protein separation 2016 ,		1	
43	Reliable response of RF MEMS LTCC packaged switches after mechanical and thermal stress. <i>Microsystem Technologies</i> , 2016 , 22, 495-501	1.7	8	
42	Long-term lifetime prediction for RF-MEMS switches. <i>Journal of Micromechanics and Microengineering</i> , 2016 , 26, 074004	2	4	
41	Influence of fabrication tolerances on the reliability of RF-MEMS capacitive switches 2015,		3	
40	MEMS packaging by using dry film resist 2015 ,		2	
39	Cycling reliability of RF-MEMS switches with gold-platinum multilayers as contact material 2015,		2	
38	RF-MEMS packaging by using quartz caps and epoxy polymers. <i>Microsystem Technologies</i> , 2015 , 21, 194	41 11/9 48	8 8	
37	Reliability of RF MEMS capacitive and ohmic switches for space redundancy configurations. <i>Microsystem Technologies</i> , 2015 , 21, 1903-1913	1.7	6	
36	. IEEE Transactions on Electron Devices, 2015 , 62, 3825-3831	2.9	7	
35	Clear evidence of mechanical deformation in RF-MEMS switches during prolonged actuation. <i>Journal of Micromechanics and Microengineering</i> , 2014 , 24, 075003	2	8	
34	Reliability of capacitive RF MEMS switches subjected to repetitive impact cycles at different temperatures 2014 ,		2	
33	RF-MEMS switch design optimization for long-term reliability. <i>Analog Integrated Circuits and Signal Processing</i> , 2014 , 78, 323-332	1.2	14	
32	Influence of temperature on the actuation voltage of RF-MEMS switches. <i>Microelectronics Reliability</i> , 2013 , 53, 706-711	1.2	14	
31	Wet release technology for bulk-silicon resonators fabrication on silicon-on-insulator substrate. <i>Journal of Micro/ Nanolithography, MEMS, and MOEMS</i> , 2013 , 12, 041206	0.7	О	
30	A simple analytical method for residual stress measurement on suspended MEM structures using surface profilometry. <i>Journal of Micromechanics and Microengineering</i> , 2013 , 23, 025025	2	19	
29	Gold-based thin multilayers for ohmic contacts in RF-MEMS switches. <i>Microsystem Technologies</i> , 2012 , 18, 965-971	1.7	7	
28	Terahertz microsensor for biomedical applications 2011 ,		1	

27	Effect of the substrate on RF power-handling capability of micro-electromechanical capacitive switches. <i>Solid-State Electronics</i> , 2011 , 65-66, 219-225	1.7	2
26	A flexible technology platform for the fabrication of RF-MEMS devices 2011 ,		17
25	Design and characterization of an active recovering mechanism for high-performance RF MEMS redundancy switches. <i>International Journal of Microwave and Wireless Technologies</i> , 2011 , 3, 539-546	0.8	3
24	Electro-thermal analysis of RF MEM capacitive switches for high-power applications 2010,		3
23	Controlling stress and stress gradient during the release process in gold suspended micro-structures. <i>Sensors and Actuators A: Physical</i> , 2010 , 162, 93-99	3.9	43
22	Electrical and mechanical properties of layered goldthromium thin films for ohmic contacts in RF-MEMS switches. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2009 , 163, 199-203	3.1	10
21	Circuital Modelling of Shunt Capacitive RF MEMS Switches 2008,		2
20	An equivalent-circuit model for shunt-connected coplanar microelectromechanical system switches for high frequency applications. <i>Journal of Applied Physics</i> , 2008 , 104, 084514	2.5	12
19	Electromechanical characterization of low actuation voltage RF MEMS capacitive switches based on DC CV measurements. <i>Microelectronic Engineering</i> , 2007 , 84, 1358-1362	2.5	17
18	Nitrogen Influence on the Photoluminescence Properties of Silicon Nanocrystals. <i>Materials Research Society Symposia Proceedings</i> , 2006 , 958, 1		
17	Broadband RF-MEMS Based SPDT 2006 ,		4
16	Broadband RF-MEMS Based SPDT 2006 ,		6
15	XPS and SIMS investigation on the role of nitrogen in Si nanocrystals formation. <i>Surface Science</i> , 2005 , 585, 137-143	1.8	29
14	Development of a gas chromatography silicon-based microsystem in clinical diagnostics. <i>Biosensors and Bioelectronics</i> , 2005 , 20, 1968-76	11.8	33
13	Ultrafast electron transfer reactions initiated by excited CT states of pushpull perylenes. <i>Chemical Physics</i> , 2002 , 275, 167-183	2.3	26
12	Bulk and surface contributions to second-order susceptibility in crystalline and porous silicon by second-harmonic generation. <i>Surface Science</i> , 2001 , 481, 105-112	1.8	36
11	Near-field optical investigation of porous silicon samples. The Philosophical Magazine: Physics of	1	
	Condensed Matter B, Statistical Mechanics, Electronic, Optical and Magnetic Properties, 2000 , 80, 611-62	1	

LIST OF PUBLICATIONS

9	182, 479-484		18	
8	Electrochemically oxidised porous silicon microcavities. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2000 , 69-70, 59-65	3.1	12	
7	Optical characterization of reverse biased porous silicon light emitting diode. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2000 , 69-70, 114-117	3.1	8	
6	Light emitting diodes based on anodically oxidized silicon/porous silicon heterojunction. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2000 , 69-70, 109-113	3.1	5	
5	Porous silicon microcavities as optical chemical sensors. <i>Applied Physics Letters</i> , 2000 , 76, 2523-2525	3.4	172	
4	Elaboration, characterization and aging effects of porous silicon microcavities formed on lightly p-type doped substrates. <i>Semiconductor Science and Technology</i> , 1999 , 14, 1052-1059	1.8	23	
3	All porous silicon microcavities: growth and physics. <i>Journal of Luminescence</i> , 1998 , 80, 43-52	3.8	46	
2	Effects of the mixing of charge transfer and molecular excitations on the resonance Raman properties of symmetric radical dimers. <i>Chemical Physics Letters</i> , 1996 , 263, 331-337	2.5	3	
1	Coupling of electrons to intermolecular phonons in molecular charge transfer dimers: A resonance Raman study. <i>Journal of Chemical Physics</i> , 1995 , 103, 2795-2809	3.9	29	